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	APPLICANT(s) Stefan GROSSE et al.	09/831722
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U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT NUMBER	PATENT DATE	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

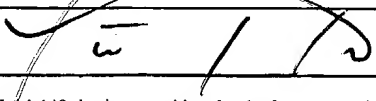
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
THM	Frame et al., "Microdischarge Devices Fabricated in Silicon", Applied Physics Letters, US, American Institute of Physics, New York, Vol. 71, No. 9, 1 Sept. 1997, pp. 1165-1167*
I	Ghanasev et al., "Surface Wave Eigenmodes in a Finite-Area Plane Microwave Plasma", Japanese Journal of Applied Physics, JP, Publication Office Japanese Journal of Applied Physics, Tokyo, Vol. 36, Part 1, No. 1A, 1997, pp. 337-344*
	Patent Abstracts of Japan, Vol. 1999, No. 05, 31 May 1999 & JP 11 045876 (Hitachi Ltd.), 16 February 1999*
	M. Roth et al., "Micro-Structure Electrodes as Electronic Interface Between Solid and Gas Phase: Electrically Steerable Catalysts for Chemical Reaction in the Gas Phase", 1997, 1st Int. Conf. on Microreaction Technology, Frankfurt/Main
THM	Kummer, "Grundlagen der Mikrowellentechnik" (Fundamentals of Microwave Technology), VEB Publishers-Technology, Berlin, 1986**

* Copy of reference is not enclosed because reference is cited and described in Search Report (copy of reference provided by International Searching Authority).

** Described in the Specification.

EXAMINER 	DATE CONSIDERED 2/24/04
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	